# Mounting arrangements Instrument hook-ups for the process industry

WIKA data sheet IN 00.34

In many applications within the process industries, measuring instruments are exposed to critical operating conditions. In order to be able to withstand, for example, strong pressure surges or extreme temperatures, WIKA attaches valves, protective devices and mounting accessories to the pressure measuring instrument, depending on the application. This ensures a stable measurement and optimises maintenance and servicing activities.

# Added value for mounting arrangements

The combination of pressure measuring instruments with matched components enables the protection and the extension of the function of the entire measuring unit. WIKA offers the qualified assembly of all elements with the pressure measuring instrument into a mounting arrangement - known as an "instrument hook-up".

The diverse portfolio of the attachable components results from the variation in the applications and customer requirements.

### Valves

# Models IV10, IV11, IV20, IV21 - Shut-off valve

Needle valve and multiport valve Block-and-bleed valve



Data sheets AC 09.19 and AC 09.21

## Models IV30, IV31, IV50, IV51 - Valve manifold

Shut-off, pressure compensating, purge and vent valves for differential pressure measuring instruments



Data sheet AC 09.23



Example of a mounting arrangement

# Model IVM – Monoflange

Compact block-and-bleed arrangement with flange connection



Data sheet AC 09.17

# Model 910.11 - Shut-off valve

Shut-off and throttle valve

Data sheet AC 09.02



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# Protective devices and adapters

## Model 910.12 - Snubber

Protection from pressure surges and pulsations in the medium



Data sheet AC 09.03

Model 910.13 – Overpressure protector

Adjustable protection against overpressure

Data sheet AC 09.04



#### Model 910.14 – Connection adapter

Adapter pieces for the mounting of valves and protective devices



Data sheet AC 09.05

Model 910.15 – Syphon

Protection from pulsations and overheating through the medium

Data sheet AC 09.06



WIKA mounts the desired components to process industry pressure measuring instruments. For the mounting, WIKA standards with respect to sealing and leak testing apply. If there are no alternative customer specifications, the assembly will be as described in the following table.

# Order of attachment

Order of attachment starting from the pressure measuring instrument		Standard alignment and options
Model 910.14 Connection adapter		For adapting threads or to enable positioning of the pressure measuring instrument through a 360° range.
Model 910.12 Snubber		Adjustment screw will be aligned to the front, in the direction of the dial.
Model 910.13 Overpressure protector		Adjustment screw (longer side) will be aligned to the right, as shown in the drawing.The set value, as standard, depends on the pressure element:Bourdon tube:1.1 x full scale valueDiaphragm or capsule element:Between full scale value and max. permissible overpressure
Model 910.11 Shut-off valve		<ul> <li>Shut-off valve without test connection per DIN 16270 (with vent screw)</li> <li>Shut-off valve with test connection per DIN 16271 (with vent screw)</li> <li>Shut-off valve with separate isolating test connection per DIN 16272</li> </ul>

Order of attachment starting from the pressure measuring instrument		Standard alignment and options
Models IV10, IV11, IV20, IV21 Shut-off valve (square or flat version)		Vent connections (if available) point to the rear. All T-bar handles, for safety reasons, will be supplied in fully closed position.
Models IV30, IV31, IV50, IV51 Valve manifold (only for differential pressure measuring instruments)		Orientation is determined by the threaded connections of both pro- cess connections on the differential pressure measuring instrument.
Model 910.15 Syphon		<ul> <li>U-form: Process connection points to the rear</li> <li>Trumpet form: Upper half of the pipe loop runs forward</li> <li>Compact form: With fixed connection thread or LH-RH adjusting nut</li> </ul>
Connecting flange or model IVM monoflange		Flanges (if available) are the first accessory component on the pro- cess side. A flange-mounting of the complete mounting arrangement to the application is thus enabled.

# **Mounting instructions**

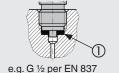
The assembly of all components is made in compliance with the specified torques and positions. Each mounting point is sealed expertly. Depending on the connection threads and the temperature and pressure ranges, PTFE tape, stainless steel sealings and other sealing rings are used (for details, see WIKA model 910.17).

### Parallel connection threads

The sealing face  ${\rm I}$  is sealed with flat gasket, lens-type sealing ring or WIKA profile sealing, usually metallic. High-temperature resistant ceramic paste is normally used for thread lubrication. The sealing point is located before or after the thread.

#### **Tapered connection threads**

The thread is wrapped with sealing material (e.g. PTFE tape). The sealing point is located in the thread.



e.g. G 1/4 per DIN 3852-E



For instrument hook-ups of oxygen applications, only tested sealants and lubricants can be used. For hazardous areas, either conductive sealants and lubricants are used or the mounting arrangement offers additional possibilities for equipotential bonding (e.g. welding points or fuse plates).

# Leak test

In line with EN 12266-1:2003, each sealing point will be 100 % tested with leak detection spray under standard test pressure. At leaking points, after the application of the leak detection spray, bubbles become visible. The bubble detection method can detect leakage rates of approx. 1.10<sup>-3</sup> mbar l/s.

For critical applications, further tests are carried out, depending on the complexity of the instrument hook-up. Besides the bubble detection method with leak detection spray, WIKA also uses the pressure drop method or leakage rate determination with helium. In accordance with the EN 1779 (test gas method B4 and B6) leak testing standard, leakage rates of better than  $1 \cdot 10^{-6}$  mbar  $\cdot$  l/s can be detectable with helium.

# **Further information**

Further information on the selection, installation and operation of pressure gauges are described in Technical Information IN 00.05.

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